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BY TELEFAX TO:
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
IN THE MATTER OF THE APPLICATION FOR PATENT

INVENTOR: Kazuhiro FUJIKAWA et al. | DOCKET NO.: 4858
APPLICATION NO.: 10/528,440 | CONFIRM. NO.: 4308
FILING DATE: March 18, 2005 | ART UNIT: 2818
TITLE OF INVENTION: | EXAMINER: T. P. LE
Method of Fabricating
Semiconductor Device

MS AF
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

November 20, 2007

RESPONSE TO THE FINAL OFFICE ACTION OF AUGUST 22, 2007, INCLUDING
AN ATTACHED COVER SHEET WITH CERTIFICATE OF TELEFAX TRANSMISSION

Dear Sir:

Please amend the above identified application as follows.

[RESPONSE CONTINUES ON NEXT PAGE]

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4858/WFF:he